



**ELECTRONIC COPY**

## LABORATORY GROWN DIAMOND REPORT

December 16, 2025	
IGI Report Number	LG756592197
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	EMERALD CUT
Measurements	9.51 X 7.04 X 4.60 MM

## GRADING RESULTS

Carat Weight	3.01 CARATS
Color Grade	D
Clarity Grade	VS 1

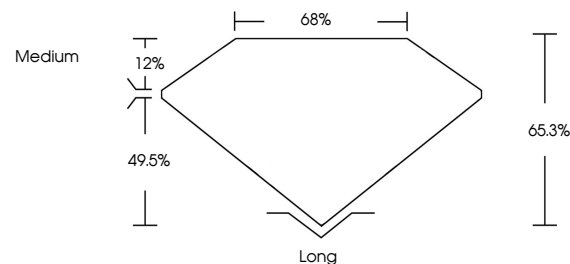
### ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG756592197

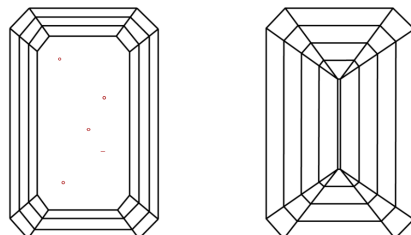
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

LG756592197  
Report verification at [igi.org](https://igi.org)

## PROPORTIONS

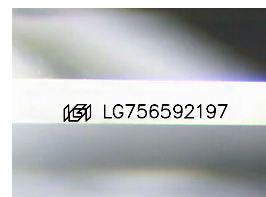


## CLARITY CHARACTERISTICS



### KEY TO SYMBOLS

Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.



Sample Image Used

## COLOR

D E F G H I J Faint Very Light Light

## CLARITY

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

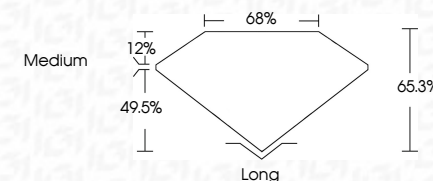
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December 16, 2025  
 IGI Report No LG756592197  
 EMERALD CITT

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**www.igi.org**